



Attorney Docket SEL 144

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In Re Application of )

Hiroki Adachi )

Serial No.: 09/437,649 )

Filed: November 10, 1999 )

For: Exposure Device, Exposure Method )  
And Method Of Manufacturing )  
Semiconductor Device )

Art Unit: 2814 )

Examiner: S. Rao )

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to:  
Commissioner for Patents,  
P.O. Box 1450, Alexandria, VA 22313-1450 on  
October 6, 2003  
(Date of Deposit)

Shannon Wallace

Name of applicant, assignee, or Registered Rep.

Shannon Wallace 10/6/03

Signature

Date

Sir:

In response to the Office Action dated June 4, 2003, a one month extension of time being submitted herewith, please amend the above-identified application as follows:

RECEIVED  
OCT 17 2003  
TECHNOLOGY CENTER 2800